	Application No.	Applicant(s)	Applicant(s)	
Notice of Allowability	10/721,080	OHTA, HIROYUKI		
	Examiner	Art Unit	· · · · · · · · · · · · · · · · · · ·	
	Long K. Tran	2818		
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLO or other appropriate IGHTS. This applicat	SED in this application. If not include communication will be mailed in due	ed course. THIS	
1. This communication is responsive to Amdt on June 17, 20	<u>005</u> .			
2. The allowed claim(s) is/are <u>15 - 19</u> .				
3. \boxtimes The drawings filed on <u>26 November 2003</u> are accepted by	the Examiner.			
 4. Acknowledgment is made of a claim for foreign priority u a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 	e been received.		· .	
2. Certified copies of the priority documents have been received in Application No				
3. Copies of the certified copies of the priority documents have been received in this national stage application from the				
International Bureau (PCT Rule 17.2(a)). * Certified copies not received:				
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 5. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 6. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.				
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/I Paper No./Mail Date 07/07/05 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Inter Pap 7. ☐ Exar 8. ☑ Exar 9. ☐ Othe	•		
David Nelms Supervisory Patent Examiner				

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DETAILED ACTION

Response to Amendment

- 1. This office action is in response to Amendment filed on March 28, 2003
- 2. Claims 1 14 and 20 24 have been withdrawn.
- 3. Claim 15 has been amended.
- 4. Claims **15 19** are presented for examination.
- This application is in condition for allowance except for the presence of claims 1
 14 and 20 24 non-elected without traverse (see office action on March 22, 2005).

Accordingly, claims 1 – 14 and 20 – 24 been cancelled.

Information Disclosure Statement

6. This office acknowledges of the following items from the Applicant:

Information Disclosure Statement (IDS) filed on July 07, 2005.

The references cited on the PTO -1449 form have been considered.

Allowable Subject Matter

- 7. Claims **15 19** are allowed.
- 6. The following is an examiner's statement of reasons for allowance: Claims **15 19** are allowable over the prior art of record because none of the prior art whether taken singularly or in combination, especially when these limitations are considered within the specific combination claimed, to teach:

a silicon nitride film cover s a lower inner surface of an isolation trench and is retracted below the surface of the semiconductor substrate; and among other limitations as cited in the independent claim 15.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on

Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Long K. Tran whose telephone number is 571-272-

1797. The examiner can normally be reached on Mon-Thu.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on 571-272-1787. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Long Tran W

August 4, 2005

David Nelms
Supervisory Patent Examiner
Technology Center 2800